Stylus & Optical Metrology Workshop:

Theory & Applications of contact and non-contact profilers

Northwestern University, Evanston, IL

The <u>NUANCE Center</u>, <u>NU-MRSEC</u>, and <u>Bruker Nano Surfaces</u> invite you to join us for technical presentations and live demonstration of the DektakXT stylus profiler and the ContourGT-K non-contact optical 3D profiler.

Wednesday, September 24

Norris University Center, Northwestern Room 1999 Campus Drive, Room 202B

9:00 - 9:30	Continental Breakfast
9:30 - 9:45	Welcome & Introductory Remarks – Chris Getz, Sales Manager - Midwest Region, Bruker Nano Surfaces
9:45 – 10:45	An Introduction to Stylus Profilometry – Eric Rufe, North America Sales Applications Manager, Bruker Nano Surfaces
10:45 - 11:00	Coffee Break
11:00 – 12:00	Non-Contact Optical Profilimetry Theory and Applications— John Thornton, Senior Applications Scientist, Bruker Nano Surfaces
12:00 – 1:00	Lunch (provided by Bruker)

Cook Hall: NUANCE, Keck-II Facility 2220 Campus Drive, Room 1149

1:00 – 5:00 Hands-on demonstration of the DektakXT stylus profiler and the ContourGT-K optical profiler - Attendee samples will be imaged as time allows. To sign up for a time slot, please see below.

There will be four 1 hour tours with 4 people maximum/tour.



To register online and sign-up for hands-on time with an instrument bit.ly/NUANCE-BNS-Workshop





